

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination GUILLORN ET AL.	
		Examiner Ron E. Pompey	Art Unit 2812	Page 1 of 1

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)		
U	Guillorn et al. ; "Fabrication of gated cathode structures using in situ grown vertically aligned carbon nanofiber as a field emission element"; Mar/April 2001, Journal of Vacuum Science Technology Vol. B 19(2) pgs. 573-578		
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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